

Docket No.: 212835US2PCT/smc



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Michio SATO, et al.

SERIAL NUMBER: 09/926,041

GROUP: 1753

FILED: August 20, 2001

EXAMINER: MCDONALD, RODNEY GLENN

FOR: COMPONENTS FOR VACUUM DEPOSITION APPARATUS AND VACUUM
DEPOSITION APPARATUS THEREWITH, AND TARGET APPARATUS

REQUEST TO CORRECT FIRST INVENTOR'S NAME

MAIL STOP ISSUE FEE
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

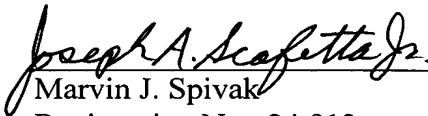
SIR:

In the matter of the above-identified application, we hereby request correction of your records to reflect the correct spelling of the first inventor's name.

The first inventor's name should be: Michio SATO

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.


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